Notice of References Cited Application/Control No. 10/079,803 Applicant(s)/Patent Under Reexamination MAEDA ET AL. Examiner Clemence Han Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,757,774	05-1998	Oka, Akihiko	370/242
*	В	US-6,430,201	08-2002	Azizoglu et al.	370/535
*	С	US-6,873,605	03-2005	Bendak et al.	370/282
*	D	US-6,014,708	01-2000	Klish, Cypryan T.	709/232
*	Ε	US-6,782,009	08-2004	Giorgetta et al.	370/539
*	F	US-6,832,052	12-2004	Marmur, Oren	398/175
*	G	US-6,895,018	05-2005	Klish, II, Cypryan T.	370/471
*	Н	US-2001/0043603	11-2001	Yu, Shaohua	370/393
*	1	US-2002/0110157	08-2002	Jorgenson et al.	370/537
*	J	US-2002/0126709	09-2002	Lauder et al.	370/535
*	К	US-2002/0191640	12-2002	Haymes et al.	370/466
*	<u>: : : : : : : : : : : : : : : : : : :</u>	US-2003/0188026	10-2003	Denton et al.	709/249
	м	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
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	Т					

NON-PATENT DOCUMENTS

MON-PATENT BOOGNETTO						
*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
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	٧					
	w					
	х					

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.